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**LABORATORY GROWN DIAMOND REPORT**

April 13, 2026  
 IGI Report Number  
 Description **LABORATORY GROWN DIAMOND**  
 Shape and Cutting Style **MARQUISE BRILLIANT**  
 Measurements **17.40 X 9.14 X 5.59 MM**

**GRADING RESULTS**

Carat Weight **5.07 CARATS**  
 Color Grade **D**  
 Clarity Grade **VVS 2**

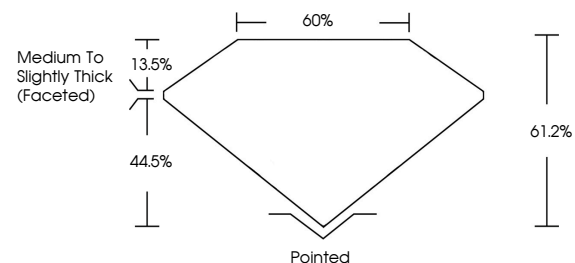
**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
 Symmetry **EXCELLENT**  
 Fluorescence **NONE**

Inscription(s)

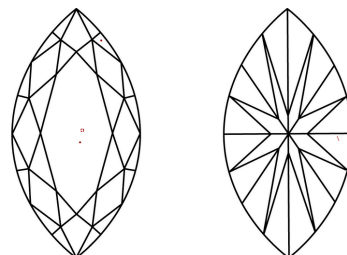
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
 Green symbols indicate external characteristics.

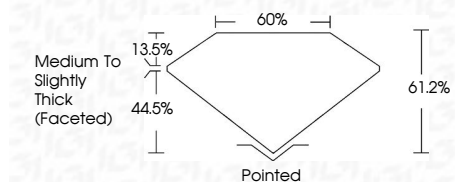
**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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**MARQUISE BRILLIANT**  
 17.40 X 9.14 X 5.59 MM  
 Carat Weight  
 Color Grade  
 Clarity Grade  
 Depth  
 Table  
 Girdle  
 Medium to Slightly Thick (Faceted)  
 Culet  
 Polish  
 Symmetry  
 Fluorescence  
 Inscription(s)  
**5.07 CARATS**  
**D**  
**VVS 2**  
**61.2%**  
**60%**  
**Pointed**  
**EXCELLENT**  
**EXCELLENT**  
**NONE**

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